



L	Hits	Search Text	DB	Time stamp
Number				
1	513361	semiconductor and (tft or (thin film transistor))	USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/05/29 13:51
			IBM TDB	
2	7977	(semiconductor and (tft or (thin film	USPAT;	2002/05/29
	1511	transistor))) and gate and drain and	US-PGPUB;	13:52
		source and offset	EPO; JPO;	13.32
		Source and orrise	DERWENT;	
			IBM TDB	
3	1075	((semiconductor and (tft or (thin film	USPAT;	2002/05/29
		transistor))) and gate and drain and	US-PGPUB;	13:52
		source and offset) and sidewall	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
5	1075	(((semiconductor and (tft or (thin film	USPAT;	2002/05/29
		transistor))) and gate and drain and	US-PGPUB;	13:53
	}	source and offset) and sidewall) and	EPO; JPO;	
		(gate electrode)	DERWENT;	
	1075	////comiconductor and /tft on /thi-	IBM_TDB	2002/05/29
	1073	<pre>((((semiconductor and (tft or (thin film transistor))) and gate and drain</pre>	USPAT; US-PGPUB;	13:54
		and source and offset) and sidewall)	EPO; JPO;	13.34
		and (gate electrode)) and (offset	DERWENT;	
		region)	IBM TDB	
7	948	((((semiconductor and (tft or (thin	USPAT;	2002/05/29
		film transistor))) and gate and drain	US-PGPUB;	13:58
		and source and offset) and sidewall)	EPO; JPO;	
		and (gate electrode)) and (offset	DERWENT;	
	5,05	region)) and (thin film)	IBM_TDB	
	5129	(257/57, 59, 66, 72, 347, 350, 329,	USPAT;	2002/05/29
		330, "331").ccls.	US-PGPUB;	13:59
			EPO; JPO;	
			DERWENT; IBM TDB	
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